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Filing Date		2004-02-10
First Named Inventor	Weim	in Lee
Art Unit		1755
Examiner Name	Koslo	w, Carol M.
Attorney Docket Number		MI22-2497

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	1	DEFRANOUX, Christophe et al., "Deep ultra-violet measurements of SiON anti-reflective coatings by spectroscopic ellipsometry", Thin Solid Films 313-314 (1998) 742-744.					
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